



Center for the Advancement of Natural Discoveries using Light Emission

SYNCHROTRON RESEARCH INSTITUTE

The methods of bunch length measurement

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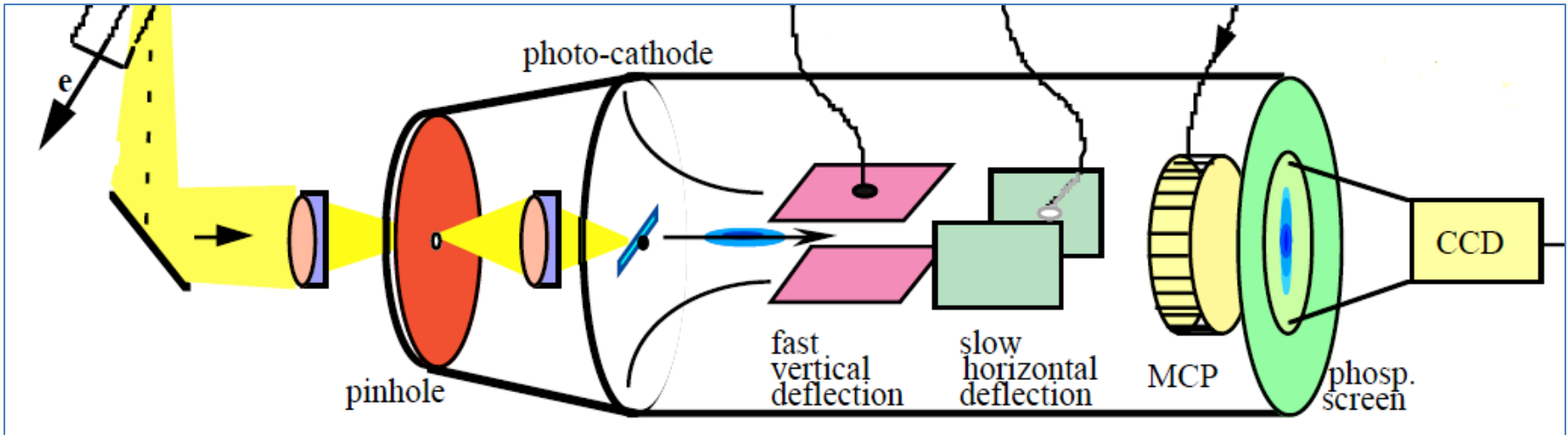
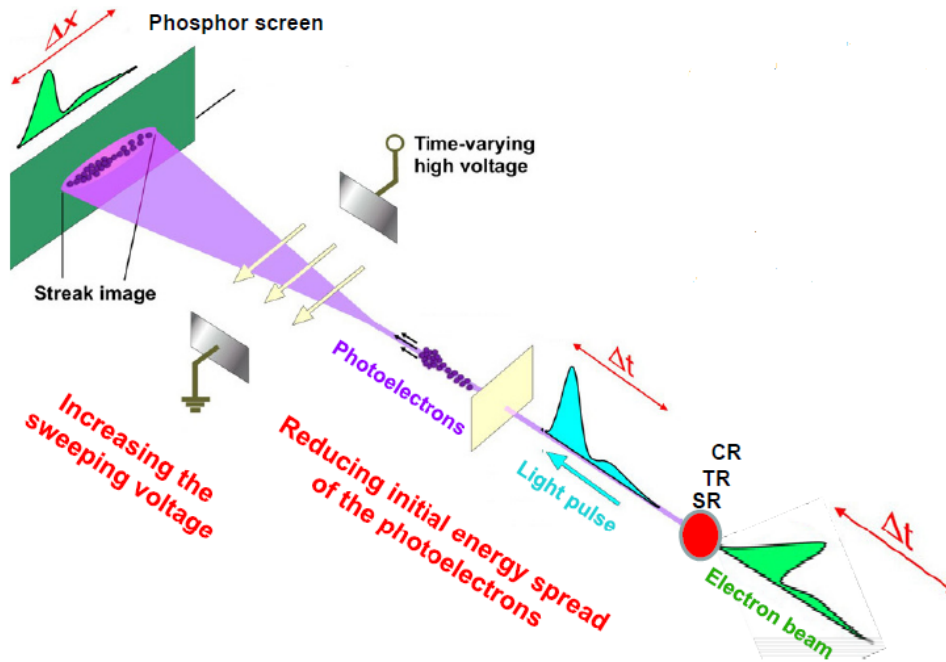
The task

- Study all measurement methods of bunch length
- Choose the suitable method for AREAL

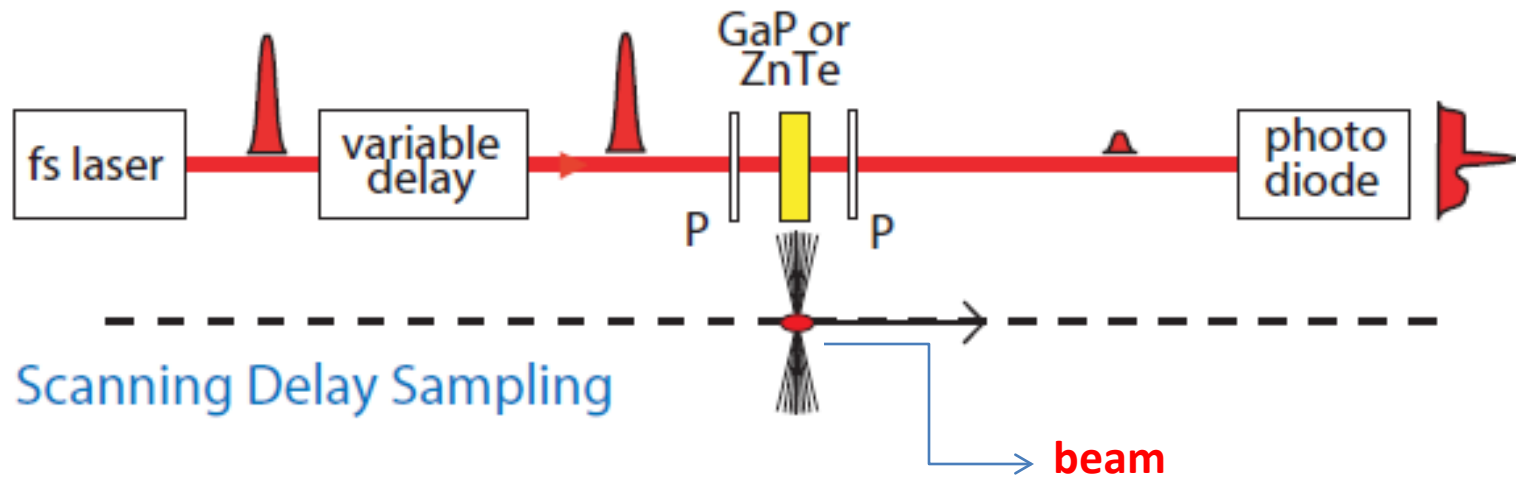
Bunch Length Measurements

- By Streak camera
- By Electro - Optical Method
- By RF Deflecting Cavity
- By RF - Phasing Method

Bunch Length Measurement by Streak camera

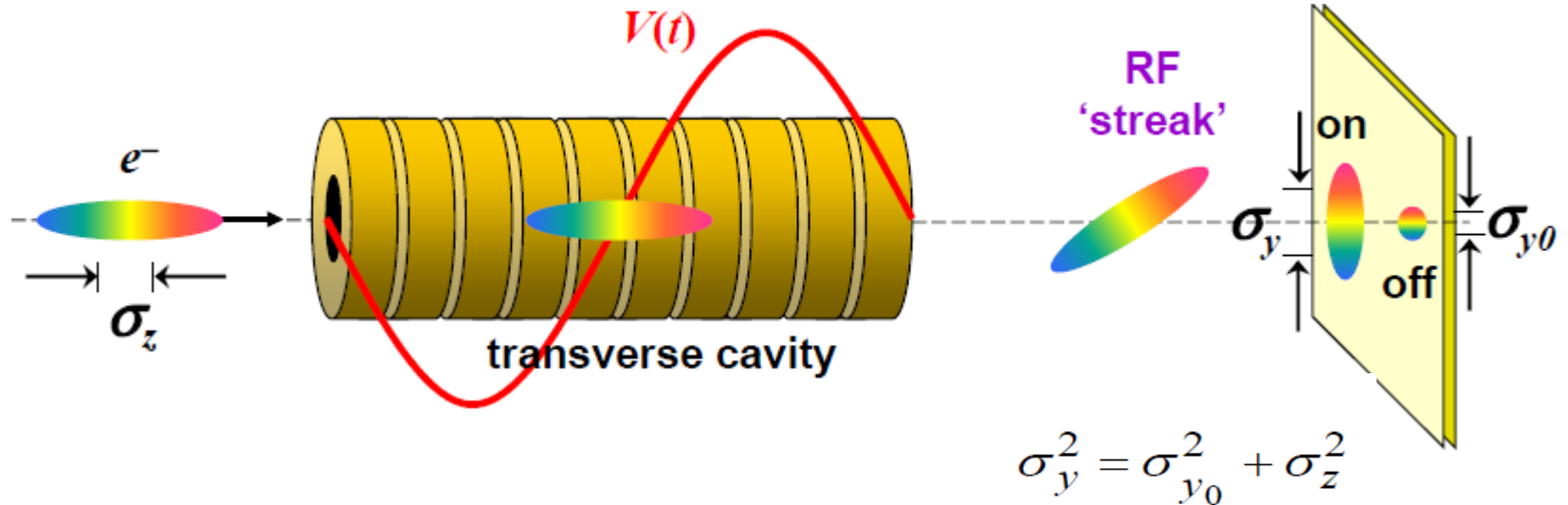


Bunch Length Measurement by Electro - Optical Method

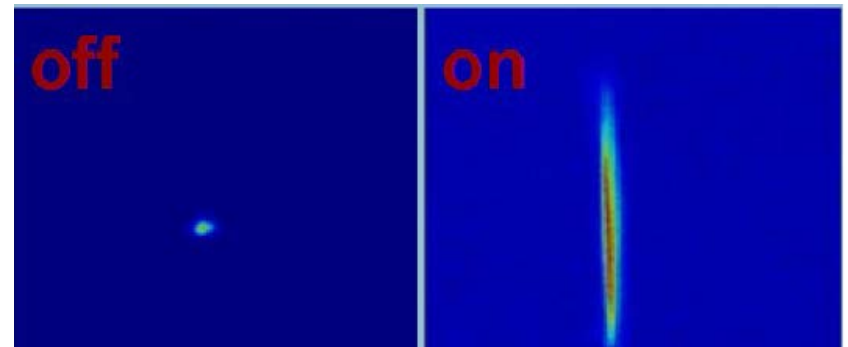


This method is based on the polarization change of a laser beam which passes through a crystal itself polarized by the electrons electric field .
Bunch length is reconstructed by measuring the intensity of the polarization change as a function of laser timing

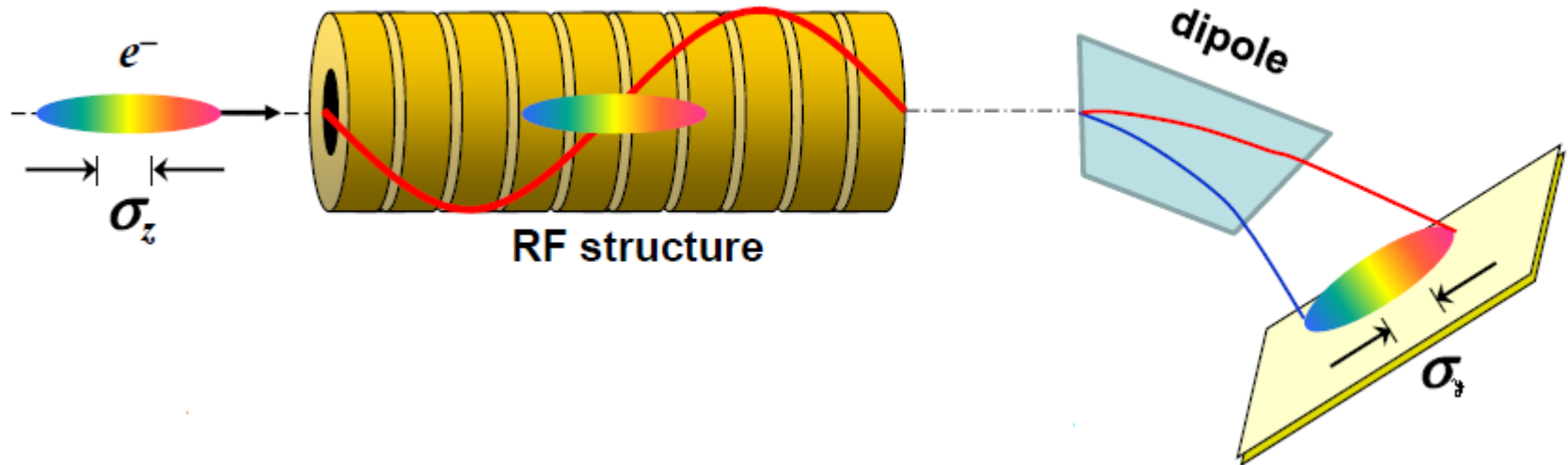
Bunch Length Measurement by RF Deflecting Cavity



Transversal deflection of the bunch. The bunch length is then deduced measuring the beam size at a downstream position using a screen.



Bunch Length Measurement by RF - Phasing Method



This method is calibrated using beam screen data and only the RF frequency needs to be known

The Method

$$E(z) = E_i + eV_0 \cos(\varphi + kz) + E_0hz, \quad (1)$$

$$E_0 \equiv E_i + eV_0 \cos \varphi_0, \quad (2)$$

$$k|z| \ll 1$$



$$\delta(z) \approx eV_0[\cos \varphi - \cos \varphi_0 - k \sin \varphi z]/E_0 + hz. \quad (3)$$

$$y = \eta \delta.$$

$$\langle y \rangle = \eta \langle \delta \rangle \approx eV_0 \eta [\cos \varphi - \cos \varphi_0]/E_0. \quad (4) \quad \langle z \rangle = 0.$$

$$\frac{\partial \langle y \rangle}{\partial \varphi} = -\frac{eV_0 \eta \sin \varphi}{E_0} \equiv a \quad (5)$$



$$\varphi = \varphi_0$$

$$y = (\eta h + ak)z \quad (6)$$

$$\sigma_y = \langle y^2 \rangle^{1/2} \quad \sigma_z = \langle z^2 \rangle^{1/2}$$

$$\longrightarrow \sigma_y^2 = (\eta h + ak)^2 \sigma_z^2 + \sigma_{y0}^2, \quad (7)$$

A voltage calibration can then easily be done by measuring the sensitivity of the position centroid, y , using small variations of the RF phase

The sing of a follows the sing of phase, we introduce x as the sing of phase.

$$a \rightarrow |a|x.$$

$$\sigma_y^2 = a^2 k^2 \sigma_z^2 (|\eta|h/|ak| + x)^2 + \sigma_{y0}^2 \quad (8)$$

$$A = a^2 k^2 \sigma_z^2, B = |\eta|h/|ak|, \text{ and } C = \sigma_{y0}^2 \longrightarrow \boxed{\sigma_z = A^{1/2}/|ak|}$$

$$\sigma_y^2 = A(B + x)^2 + C, \quad (9)$$

$$x = -1, x = +1, \text{ or } x = 0$$

$$A = \frac{\sigma_{y(\varphi_0)}^2 + \sigma_{y(-\varphi_0)}^2}{2} - \sigma_{y(0)}^2$$

2- point measurement - If crest phase beam size is much smaller than the other two, we can ignorind it.

$$\sigma_z = \left(\frac{\sigma_{y(\varphi_0)}^2 + \sigma_{y(-\varphi_0)}^2}{2} \right)^{1/2} / ak$$

Example

This refined RF phasing method has been tested at LCLS and the results are compared to those of the transverse deflector

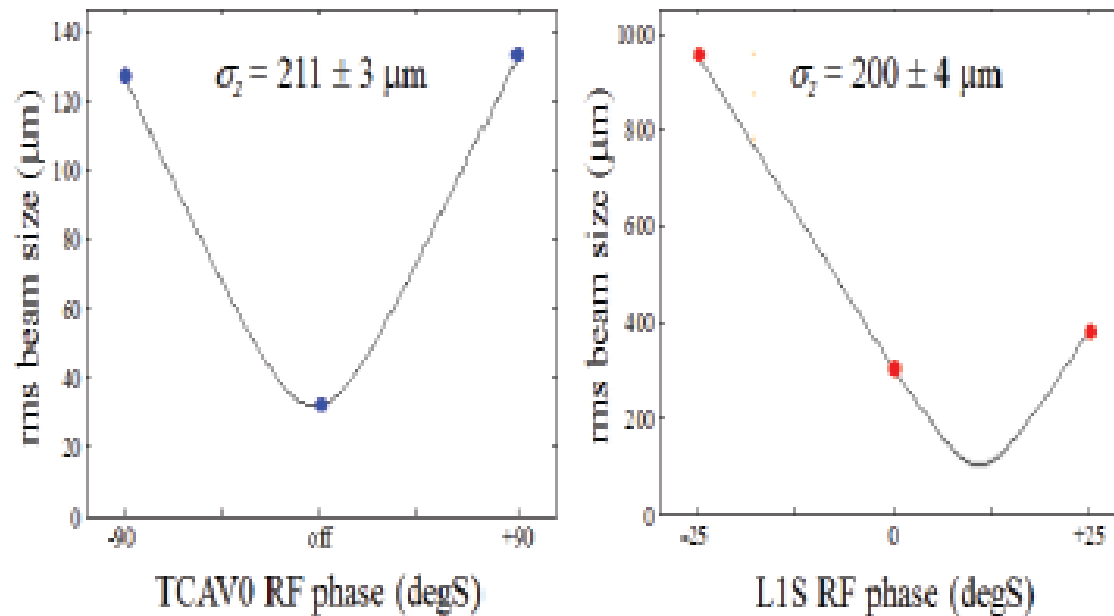


Figure 7: Measured rms beam sizes in *LCLS* injector at 20 pC vs. RF phase (transverse cavity phase at left, and pre-BC1 accelerating phase, L1S, at right). The two independent bunch length measurements agree to within 5% here.

THANK YOU FOR ATTENTION

